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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

AKIYAMA ET AL.

Atty. Ref.: 1035-548; Confirmation No.: 3055

Appl. No. 10/516,333

TC/A.U. 2826

Filed: November 30, 2004

Examiner: Abraham, Fetsum

For: PIEZOELECTRIC ELEMENT BASED ON SUPERHIGH-ORIENTED ALUMINUM  
NITRIDE THIN FILM AND MANUFACTURING METHOD THEREOF

\* \* \* \* \*

April 25, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE**

This is in response to the Office Action dated March 27, 2006, relating to the  
above-identified patent application.

The Examiner has required restriction to one of the following inventions under 35 U.S.C.

121:

- I. Claims 1-8, 17-23 drawn to a structure, classified in class 257, subclass 763.
- II. Claims 9-16, drawn to a method of making a structure, classified in class 438, subclass 683.

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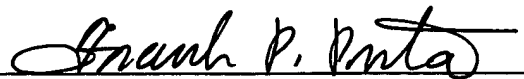
For further prosecution in the present application, Applicant elects claims 1-8 and 17-23 in Group I for further prosecution in the present application.

Applicant specifically reserves the right to file a divisional application on the non-elected claims 9-16 during the pendency of the present application.

Prompt action on the merits of the elected claims 1-8 and 17-23 is earnestly solicited.

Respectfully submitted,

**NIXON & VANDERHYE P.C.**

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